PATENT

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Williams et al.

Serial No.: 10/647,874

Filed: August 25, 2003

For: HEAT SINKS INCLUDING NONLINEAR PASSAGEWAYS

Examiner: Unknown

Group Art Unit: 2826

Attorney Docket No.: 2269-4209.2US

(99-0174.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

December 10, 2003

Rachael M. Harris

Name (Type/Print)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with the duty to disclose information material to patentability pursuant to 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 or PTO/SB/08 be considered by the Examiner and made of record. Copies of the listed documents are enclosed pursuant to 37 C.F.R. § 1.98(a).

In accordance with 37 C.F.R. § 1.97(g) and (h), filing of this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b). Further, no representation is made by Applicants herein that no other possible material information as defined in 37 C.F.R. § 1.56 (b) exists.

U.S. Patent Documents

U.S. Patent No.	Publication Date	<u>Patentee</u>
US - 6,251,488	06/26/01	Miller et al.
US - 6,259,962	07/10/01	Gothait
US - 6,268,584	07/31/01	Keicher et al.
US - 6,391,251	05/21/02	Keicher et al.

Other Documents

U.S. Patent Application Publication No. 2002/0171177 A1 to Kritchman et al., dated November 21, 2002

U.S. Patent Application Publication No. 2003/0151167 A1 to Kritchman et al., dated August 14, 2003

MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22

MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, 1 page

Webpage, Objet Prototyping the Future, Objet FullCure700 Series, 1 page

Webpage, Objet Prototyping the Future, How it Works, 2 pages

Applicants offer to supply any explanation or discussion of the documents which the Examiner feels is necessary or desirable and which is requested.

This Supplemental Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits.

Respectfully submitted,

Tawni L. Wilhelm Registration No. 47,456

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Date: December 10, 2003

TLW/rmh

Enclosures: Form PTO-1449 or PTO/SB/08

Copy of documents cited

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Approved for use through 10/31/2002. OMB 0651-0031

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Substitute	for form 1449A/PTO	-			Complete if Known	
INFO	ORMATION	DI	SCLOSURE	Application Number	10/647,874	
STATEMENT BY APPLICANT		Filing Date	August 25, 2003			
SIA	I EMENT D		IIDICANI	First Named Inventor	Williams et al.	
				Group Art Unit	2826	
	(use as many shee	ets as	necessary)	Examiner Name	Unknown	
Sheet	1	of	2	Attorney Docket Number	4209.2US (99-0174.02/US)	$\overline{\mathcal{I}}$

U.S. PATENT DOCUMENTS					
Examiner Cite		Document Number	Publication Date	Name of Patentee or Applicant of	Pages, Columns, Lines, Where Relevant
Initials *	No.	Number - Kind Code ² (if known)	MM-DD-YYYY	Cited Document	Passages or Relevant Figures Appear
		US- 6,251,488	06/26/01	Miller et al.	
		US- 6,259,962	07/10/01	Gothait	
		US- 6,268,584	07/31/01	Keicher et al.	V- V-
		US- 6,391,251	05/21/02	Keicher et al.	
		US-			
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	FOREIGN PATENT DOCUMENTS						
Examiner Cite	Foreign Patent Document		Name of Patentee or	Pages, Columns, Lines,			
Initials* No.1		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known) Publication Date MM-DD-YYYY		Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	T ⁶	
	 					-	

Examiner Signature	Date Considered	

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Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. Skind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.



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Substitute for form 1449A/PTO Complete if Known Application Number 10/647,874 INFORMATION DISCLOSURE Filing Date August 25, 2003 STATEMENT BY APPLICANT Williams et al. First Named Inventor 2826 Group Art Unit (use as many sheets as necessary) **Examiner Name** Unknown 4209 2US (99-0174-02/US Attorney Docket Number

	OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS					
Examiner Cite Initials * No. 1		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher city and/or country where published.				
		U.S. Patent Application Publication No. 2002/0171177 A1 to Kritchman et al., dated November 21, 2002				
		U.S. Patent Application Publication No. 2003/0151167 A1 to Kritchman et al., dated August 14, 2003				
		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22				
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, 1 page				
		Webpage, Objet Prototyping the Future, Objet FullCure700 Series, 1 page				
		Webpage, Objet Prototyping the Future, How it Works, 2 pages				

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Signature	Considered	

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¹ Unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.